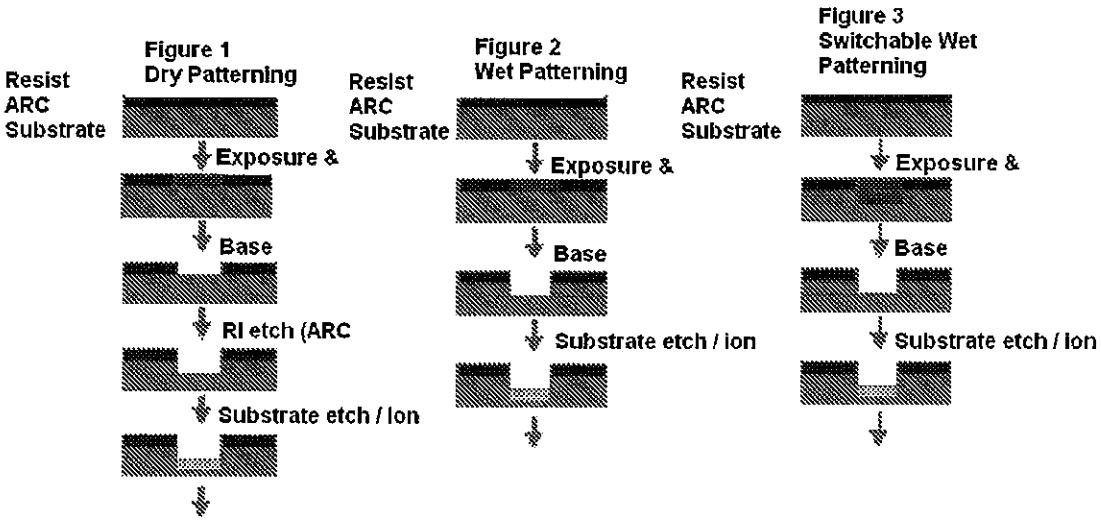
Figure 1
Dry Patterning
Resist
ARC
Substrate
Exposure &
Base
RI etch (ARC
Substrate etch / Ion
Figure 2
Wet Patterning
Resist
ARC
Substrate
Exposure &
Base
Substrate etch / Ion
Figure 3
Switchable Wet
Patterning
Resist
ARC
Substrate
Exposure &
Base
Substrate etch / Ion